



EXPEDITED PROCEDURE – EXAMINING GROUP 2822

09/858,337

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-------------|---|-----------------|----------------|
| Applicant: | William J. Schaff et al. | Examiner: | Khanh B. Duong |
| Serial No.: | 09/858,337 | Group Art Unit: | 2822 |
| Filed: | May 15, 2001 | Docket No.: | 1153.044US1 |
| Title: | AIN COATED HETEROJUNCTION FIELD EFFECT TRANSISTOR AND METHOD OF FORMING AN AIN COATING | | |

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the final Office Action mailed December 3, 2003, please amend the application as follows:

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